

**Search Notes**

Application/Control No.

10/698,486

Examiner

David Y. Chung

Applicant(s)/Patent under  
Reexamination

KIM, DAE YOU

Art Unit

2871

**SEARCHED**

Class	Subclass	Date	Examiner
349	149	3/7/2005	DC
349	150	3/7/2005	DC
349	151	3/7/2005	DC
349	152	3/7/2005	DC

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST search report	3/7/2005	DC